



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daniel KOPF et al.

Group Art Unit: 2828

Application No.: 10/581,893

Examiner: S. HAGAN

Filed: September 29, 2006

Docket No.: 120391

For: HIGH-REPETITION LASER SYSTEM FOR GENERATING ULTRA-SHORT PULSES ACCORDING TO THE PRINCIPLE OF CAVITY DUMPING (AS AMENDED)

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the October 14, 2008 Office Action, with the attached Petition for Extension of Time extending the period for response, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**